Fax:23698454

Jul 5 '05 17:31

P. 03/08

Customer No.: 31561 Application No.: 10/605,214 Docket No.: 9789-US-PA

## IN THE CLAIMS

Please amend the claims in the application according to the following listing of claims.

- 1. (previously presented) A method of fabricating an organic light emitting diode device, comprising:
  - (a) providing a substrate having an organic light emitting diode unit thereon;
- (b) forming a passivation layer on the substrate to cover the organic light emitting diode unit; and
- (c) providing an ion beam to perform surface treatment on the passivation layer, wherein the ion beam is provided by ion implantation.
- 2. (original) The method according to Claim 1, wherein the passivation layer is formed of either silicon nitride or silicon oxide.

Claims 3-4 (cancelled)

- 5. (original) The method according to Claim 1, further comprising the step after step (c):
- (d) forming a plastic layer on the passivation layer.

## BEST AVAILABLE COPY

Fax:23698454

Jul 5 '05 17:31

P. 04/08

Customer No.: 31561
Application No.: 10/605,214
Docket No.: 9789-US-PA

- 6. (original) The method according to Claim 5, further comprising repeating the steps (b) to (d) at least once.
- 7. (original) The method according to Claim 5, wherein the plastic layer is made of ultra high molecular weight polyethylene or PMMA.
- 8. (currently amended) A method of forming a solid passivation layer to protect an electronic device formed on a substrate, comprising:
  - (a) forming a passivation layer to cover the electronic device; and
- (b) providing an ion beam to perform surface treatment on the passivation layer, wherein the ion beam is provided by ion implantation; and
  - (c) forming a plastic layer on the passivation layer.
- 9. (original) The method according to Claim 8, wherein the passivation layer is made of silicon nitride or silicon oxide.

Claims 10-12 (cancelled)

## BEST AVAILABLE COPY

Fax:23698454

Jul 5 '05 17:32

P. 05/08

Customer No.: 31561 Application No.: 10/605,214 Docket No.: 9789-US-PA

- 13. (currently amended) The method according to Claim \(\frac{128}{8}\), further comprising the step of repeating steps (a) to (c) at least once.
- 14. (currently amended) The method according to Claim 128, wherein the plastic layer is made of ultra high molecular polyethylene or PMMA.